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CLAIMS

What is claimed is:

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1. A method of making a semiconductor coated nanoparticle comprising a layer of at least one semiconducting material covering at least a portion of at least one surface of a nanoparticle, comprising:

- (A) dispersing the nanoparticle under suitable conditions to provide a dispersed nanoparticle; and
- (B) depositing at least one semiconducting material under suitable conditions onto at least one surface of the dispersed nanoparticle to produce the semiconductor coated nanoparticle.
- 2. The method of claim 1, wherein the nanoparticle substrate comprises a fullerene.
- 3. The method of claim 2, wherein the fullerene comprises at least one of C_{60} molecules, C_{72} molecules, C_{84} molecules, C_{96} molecules, C_{108} molecules, C_{120} molecules, ovoid molecules, single-walled carbon nanotubes, and multi-walled carbon nanotubes.
- 15 4. The method of claim 2, wherein the fullerene comprises a surface modified fullerene.
 - 5. The method of claim 1, wherein the at least one surface of the dispersed nanoparticle is activated.
 - 6. The method of claim 1, wherein the semiconducting material comprises at least one of photonic bandgap engineered materials; III-V and II-VI binary, ternary, and quaternary compound semiconductors; metallic oxides; polymers; liquid crystals; and suitable organic compounds.
 - 7. The method of claim 1, wherein the semiconducting material comprises at least one of ZnS, CdS, CdSe, GaAs, InP, GaS, TiO₂, and Fe₂S₃.
- 8. The method of claim 1, wherein the semiconducting material comprises at least one of CdS and CdSe.
 - 9. The method of claim 1, wherein the semiconducting material is capable of at least one of absorbing and emitting light.
 - 10. The method of claim 1, wherein dispersing the nanoparticle is accomplished by chemical functionalization.
- The method of claim 10, wherein chemical functionalization comprises hydroxylation.
 - 12. The method of claim 1, wherein dispersing the nanoparticle is accomplished by surfactant addition.

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13. The method of claim 12, wherein the surfactant comprises at least one of sodium dodecylsulfate, dodecyltrimethyl ammonium bromide, N-hexadecyl-N(2-hydroxy-ethyl)-N,N'-dimethylammonium bromide, sodium dodecyl(benzenesulfonate), and dodecyl(benzene) trimethylammonium halide.

- 5 14. The method of claim 1, wherein depositing of step (B) comprises contacting the at least one surface with a solution comprising precursors to the semiconducting material.
 - 15. The method of claim 1, wherein step (B) further comprises adding at least one capping agent to the solution.
- 16. The method of claim 15, wherein the at least one capping agent comprises at least one of n-tetradecylphosphonic acid, ethanol, and an organic thiol.
 - 17. The method of claim 1, wherein step (B) further comprises catalyzed growth of the semiconducting material onto the at least one surface.
 - The method of claim 17, further comprising(C) quenching the catalyzed growth.
- 15 19. The method of claim 1, further comprising
 (C) inserting the semiconductor coated nanoparticle in vivo.
 - A semiconductor coated nanoparticle comprising:
 a nanoparticle; and

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- a semiconductor coating, wherein the semiconductor coating coats at least a portion of the nanoparticle.
 - 21. The semiconductor coated nanoparticle of claim 20, wherein the nanoparticle comprises a fullerene.
 - 22. The semiconductor coated nanoparticle of claim 21, wherein the fullerene comprises at least one of C_{60} molecules, C_{72} molecules, C_{84} molecules, C_{96} molecules, C_{108} molecules, ovoid molecules, C_{120} molecules, single-walled carbon nanotubes, and multi-walled carbon nanotubes.
 - 23. The semiconductor coated nanoparticle of claim 20, wherein the fullerene comprises a surface modified fullerene.
- 24. The semiconductor coated nanoparticle of claim 20, wherein the semiconductor coating comprises at least one of photonic bandgap engineered materials; III-V and II-VI binary, ternary, and quaternary compound semiconductors; metallic oxides; polymers; liquid crystals; and suitable organic compounds.

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25. The semiconductor coated nanoparticle of claim 20, wherein the semiconductor coating comprises at least one of ZnS, CdS, CdSe, GaAs, InP, GaS, TiO₂, and Fe₂S₃.

- 26. The semiconductor coated nanoparticle of claim 20, wherein the semiconductor coating comprises at least one of CdS and CdSe.
- 5 27. The semiconductor coated nanoparticle of claim 20, wherein the semiconductor coating is capable of at least one of absorbing and emitting light.